

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET NO. 1089.0350001/DKSC/TUM	APPLICATION NO. To Be Assigned (Divisional of U.S. Appl. No. 09/534,573; Filed: March 27, 2000) <u>10/050586</u>
	APPLICANT QIU et al.	
	FILING DATE January 18, 2002	GROUP To Be Assigned <u>2834</u>

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
<i>TMD</i>	AA1	4,643,984	02-17-1987	Abe et al.	501	134	
<i>AMB</i>	AB1	4,829,033	05-09-1989	Menashi et al.	501	139	
<i>TMD</i>	AC1	4,832,939	05-23-1989	Menashi et al.	501	139	
	AD1				423	558	
	AE1						
	AF1						
	AG1						
	AH1						
	AI1						
	AJ1						
	AK1						

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION
<i>TMD</i>	AL1	WO 90/06292	6/14/1990	WIPO			x Yes No
<i>AMB</i>	AM1	EP 911891A2	4/28/1999	Europe			Yes No
	AN1						Yes No
	AO1						Yes No
	AP1						Yes No

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)			
<i>TMD</i>	AR	1	W-Ping XU et al., Application of Hydrothermal Mechanism For Tailor-Making Perovskite Titanate Films, IEEE Proc. Of the 9 th International Symposium on Electrets in Shanghai, China, pp. 617-622 (Sept. 25-30, 1996)
	AS	1	
	AT	1	

EXAMINER <i>Alvin M. Ruppberg</i>	DATE CONSIDERED <u>7/17/03</u>
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	